

9/30/03

FORM PTO-1449				Atty. Docket No. XA-9947		Appln. No.	
<b>LIST OF DOCUMENTS CITED BY APPLICANT</b>							
				Applicant Nobuyuki SUGII et al.			
				Filing Date HEREWITH		Group	
<b>U.S. PATENT DOCUMENTS</b>							
Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
LP	AA	6,563,152	05/13/03	Roberds et al.	257	288	
	AB	6,475,869	11/05/02	Yu	438	303	
	AC	6,403,981	06/11/02	Yu	257	63	
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
<b>FOREIGN PATENT DOCUMENTS</b>							
Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
LP	AJ	2002-16255	01/18/02	Japan			Abstract
	AK	9-321307	12/12/97	Japan			Abstract
	AL	2000-286418	10/13/00	Japan			Abstract
	AM	2003-17710	01/17/03	Japan			Abstract
	AN						
	AO						
<b>OTHER</b> (including author, title, date, pertinent pages, etc.)							
LP	AP	Hisamoto et al., "A Folded-channel MOSFET for Deep-sub-tenth Micron Era," Proceedings of the International Electronic Device Conference (IEDM), 1988, pp. 1032-1034.					
	AQ	Nikkei Electronics, July 16, 2001, pp. 63-70.					
	AR						
Examiner LONG PHAM				Date Considered 3/26/05			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							